

Notice of References Cited	Application/Control No. 10/532,082		Applicant(s)/Patent Under Reexamination OCHI ET AL.	
	Examiner ALTREV C. SYKES		Art Unit 1794	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0116025	06-2004	Gogins et al.	442/340
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Theron et al. Electrostatic field-assited alignment of electrospun nanofibres. Nanotechnology, 12, 2001, 384-390.
	V	Li et al. Electrospinning of Polymeric and Ceramic Nanofibers as Uniaxially Aligned Arrays. Nano Letters, Vol. 3, 2003, 1167-1171.
	W	Deitzel et al. Controlled deposition of electrospun poly(ethylene oxide) fibers. Polymer 42, 2001, 8163-8170.
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.